



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 7449  
Kazuhiro OTSU et al. : Docket No. 2002-0208A  
Serial No. 10/067,370 : Group Art Unit 2818  
Filed February 7, 2002 : Examiner Thao P. Le

SEPARATING MACHINE FOR THINNED  
SEMICONDUCTOR SUBSTRATE AND  
SEPARATION METHOD

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated April 9, 2003 in which restriction has been required, Applicants hereby elect the invention identified as Group I (claims 1-5, and 9) without traverse.

Favorable action on the merits is now requested.

Respectfully submitted,

Kazuhiro OTSU et al.

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May 9, 2003

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